

PTO-1449	Application No. 09/909,699	Applicant(s) Cheng-Lee Nee et al.		
Information Disclosure Citation in an Application	Docket Number 062891.0541	Group Art Unit 2661	Filing Date July 20, 2001	

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## U.S. PATENT DOCUMENTS

	DOCUMENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE
A	6,553,006 B1	04/22/03	Kalliokulju et al.	370	310	08/09/99
B	6,636,721 B2	10/21/03	Threadgill et al.	455	12.1	08/01/01
C	6,708,031 B2	03/16/04	Purnadi et al.	455	436	12/05/00
D	6,731,936 B2	05/04/04	Chen et al.	455	437	08/20/01
E	6,732,167 B1	05/04/04	Swartz et al.	709	223	11/30/99
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## FOREIGN PATENT DOCUMENTS

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